

GP 1765

Patent
Attorney's Docket No. 015290-238

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

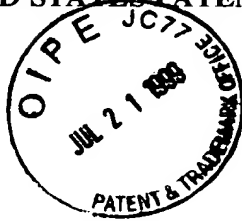
In re Patent Application of

Jeffrey HUNG et al.

Application No.: 09/002,007

Filed: December 31, 1997

For: ETCHING PROCESS FOR ORGANIC
ANTI-REFLECTIVE COATING



) Group Art Unit: 1765

) Examiner: L. Vinh
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REPLY TRANSMITTAL LETTER

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Enclosed is a reply for the above-identified patent application.

☐ A Petition for Extension of Time is also enclosed.

☐ Also enclosed is _____

☐ _____ statement(s) claiming small entity status
☐ are also enclosed ☐ were submitted previously.

☐ A Request for Entry and Consideration of Submission under 37 C.F.R. § 1.129(a) is also enclosed.

☐ No additional claim fee is required.

☒ An additional claim fee is required, and is calculated as shown below:

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AMENDED CLAIMS					
	NO. OF CLAIMS	HIGHEST NO. OF CLAIMS PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	ADDT'L FEE
Total Claims	21	MINUS 20 =	1	x \$18.00 =	18.00
Independent Claims	3	MINUS 3 =	0	x \$78.00 =	
If Amendment adds multiple dependent claims, add \$260.00					
Total Amendment Fee					
If small entity status is claimed, subtract 50% of Total Amendment Fee					
TOTAL ADDITIONAL FEE DUE FOR THIS AMENDMENT					\$18.00

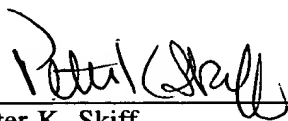
☒ A claim fee in the amount of \$ 18.00 is enclosed.

☐ Charge \$ _____ to Deposit Account No. 02-4800.

The Commissioner is hereby authorized to charge any appropriate fees under 37 C.F.R. §§ 1.16, 1.17 and 1.21 that may be required by this paper, and to credit any overpayment, to Deposit Account No. 02-4800. This paper is submitted in triplicate.

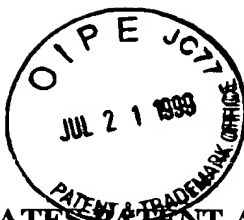
Respectfully submitted,

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Date: July 21, 1999



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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)

Jeffrey HUNG et al.)

Group Art Unit: 1765

Application No.: 09/002,007)

Examiner: L. Vinh

Filed: December 31, 1997)

For: ETCHING PROCESS FOR ORGANIC)
ANTI-REFLECTIVE COATING)

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AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Official Action dated April 21, 1999, please amend the above-identified application as follows.

IN THE CLAIMS:

Please amend the claims and add new claims as follows:

CA1 93. (Amended) The process of Claim 1, wherein the ARC is exposed by channels forming [an interconnecting network] a circuit pattern previously etched in ^{the} a photoresist covering the ARC.

[Claim 4, line 2, change "essential" to --essentially--.]

A2 10. (Amended) The process of Claim 1, wherein the plasma is generated adjacent a substrate including the ARC, the plasma generating device including a dielectric window facing the substrate and [generating device includes] an antenna outside the reaction

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